## Application/Control No. Applicant(s)/Patent Under Reexamination 09/996,120 CHAN ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 Edna Wong 1753 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY US-4,126,934 11-1978 Richter et al. 29/623.1 US-3,668,014 06-1972 В Katsoulis et al. 429/42 US-3,160,526 12-1964 С PAUL RUETSCHI 429/347 US-D E US-F US-US-G Н US-US-US-US-Κ US-US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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